Notice of References Cited Application/Control No. 10/512,105 Examiner AMY HSU Applicant(s)/Patent Under Reexamination VAN BEENEN, MARTIJN Art Unit 2622 Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,710,860 A	01-1998	Kim, Tea Wan	386/118
*	В	US-5,803,424 A	09-1998	Keehn et al.	248/489
*	C	US-5,905,546 A	05-1999	Giulie et al.	348/842
*	D	US-5,988,823 A	11-1999	Wong, Ken E.	359/601
*	Е	US-6,144,419 A	11-2000	Schmidt, Robert P.	348/842
*	F	US-6,302,546 B1	10-2001	Kordiak, John A.	359/608
*	G	US-6,356,439 B1	03-2002	Schmidt, Robert P.	361/683
*	Ι	US-6,419,367 B1	07-2002	Dion et al.	359/612
	-	US-			
	J	US-			
	K	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
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	R					
	Ø					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	×	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.